

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/734,413	KIM ET AL.		
Examiner	Art Unit		
Sherrie Hsia	2622		

SEARCHED					
Class	Subclass	Date	Examiner		
348	614, 607, 624, 914	6/06	an		
375	229, 232,				
	286, 346				
	260				
H04N	5/21				
	5/213				
			- 22		

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			

(1	SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
				DATE		EXMR
EAST				6/06		M
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